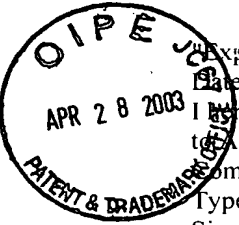


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Docket No. P1296IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): BIN YU

SERIAL NO.: 09/826,472

EXAMINER: RON E. POMPEY

FILED: APRIL 4, 2001

ART UNIT: 2812

TITLE: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE
HAVING A NITRIDE/HIGH-K/NITRIDE GATE DIELECTRIC STACK
BY ATOMIC LAYER DEPOSITION (ALD) (as amended)COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231

TRANSMITTAL LETTER

Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are the following:

1. Notice of Appeal (2 pages);
2. Appointment of Associate Attorney (2 pages);
3. Check No. 6056 in the amount of \$320.00; and
4. Post card in acknowledgment of receipt of all transmitted materials.

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Respectfully submitted,



Kenneth L. Green
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KLG/pa
Date: April 28, 2003
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